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I hereby certify that this correspondence is being hand filed with the United States Patent and Trademark Office in Washington, D.C. on
June 11, 2002


N. Slaveter

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Kunihiro TAKATANI

Serial No.: 09/557,961

Filing Date: April 25, 2000

For: ELECTRODE STRUCTURE ON P-
TYPE III GROUP NITRIDE
SEMICONDUCTOR LAYER AND
FORMATION METHOD THEREOF

Examiner: Donghee Kang

Group Art Unit: 2811

(NE)
15/B

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T. Flower

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AMENDMENT UNDER 37 CFR 1.116

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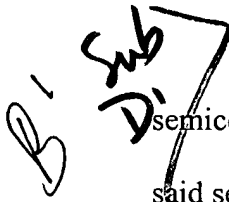
Sir:

In response to the final Office Action dated February 13, 2002, please amend this
application as follows:

AMENDMENTS

In the Claims:

Please amend claims 1 and 8 as follows:

- 
1. (Twice Amended) An electrode structure on a p-type III group nitride semiconductor layer, comprising first, second and third electrode layers successively stacked on said semiconductor layer,